## Notice of References Cited Application/Control No. 10/524,582 Applicant(s)/Patent Under Reexamination IGUCHI ET AL. Examiner Tan Ho Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-5,420,596 A	05-1995	Burrell et al.	343/700MS
*	В	US-5,585,807 A	12-1996	Takei, Ken	343/702
*	С	US-6,552,686 B2	04-2003	Ollikainen et al.	343/700MS
*	D	US-6,650,294 B2	11-2003	Ying et al.	343/700MS
*	E	US-5,966,097 A	10-1999	Fukasawa et al.	343/700MS
*	F	US-6,859,174 B2	02-2005	Kane et al.	343/700MS
	G	US-			
	Н	US-			
	- 1	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	ď					
	R					
	S					
	۲					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	×	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.